

EXAM XPS

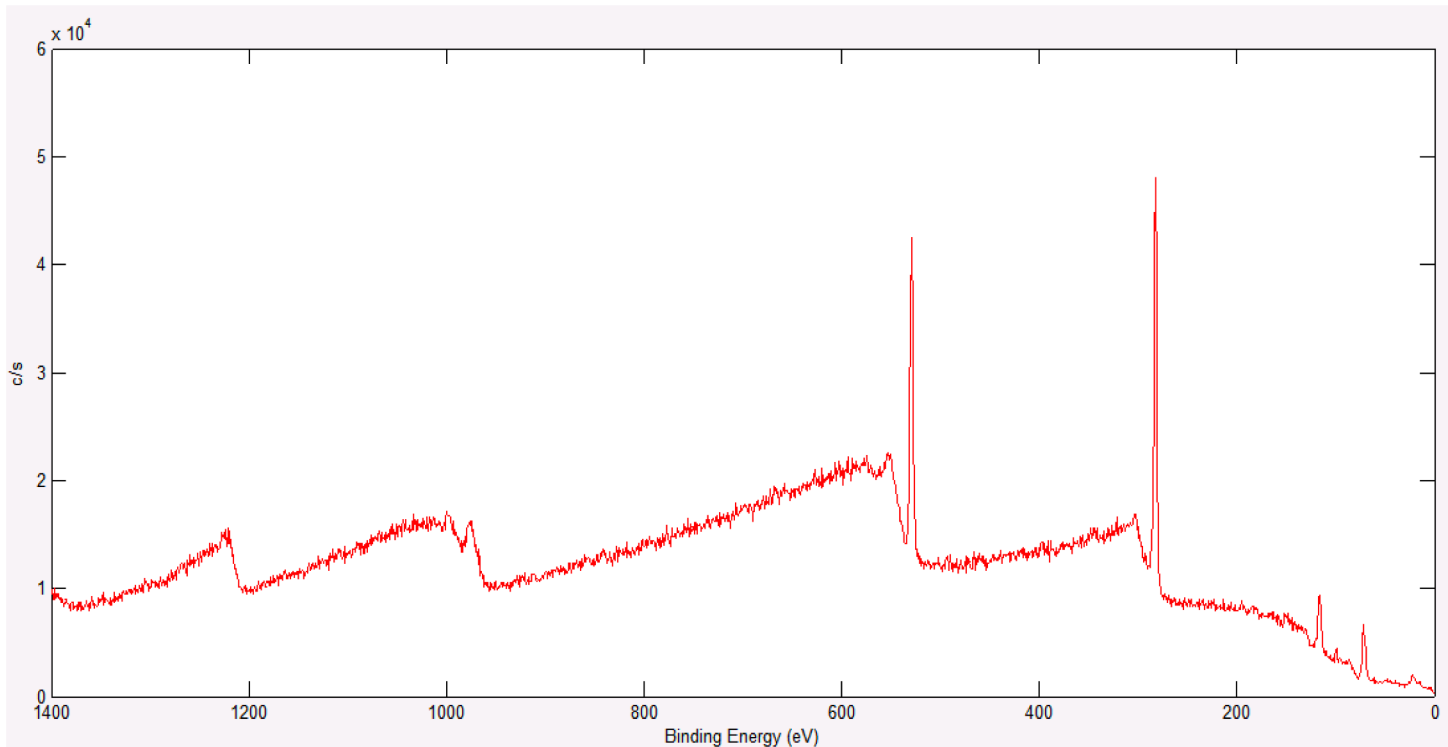
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Question 1

An aluminium coating is measured using the Al K α X-ray source (1486.6 eV) of an XPS. Native oxides and adventitious carbon contamination are expected.

- 1) On the survey below, assign the dominant photoelectron and Auger lines, and show the contribution of the secondary electrons
- 2) Briefly describe how the background is formed

- 3) Is there a way to shift the Auger peaks with respect to the photoelectron peaks?



	Photoelectrons BE, BE scale [eV]		
	1s	2s	2p
Carbon	285		
Oxygen	531	23	
Aluminium		118	73

	Auger transitions, Al K α source, BE scale [eV]				
	KVV	KL1L1	KL1L23	KL23L23	L23M1M23
Carbon	1223				
Oxygen		1013	999	978	
Aluminium					1419

Question 2

During an XPS measurement, photoelectrons are emitted from the material being exposed to X-rays. These photoelectrons are said to reflect the surface properties of the material. In a couple of lines, explain why XPS is a surface sensitive technique, what is the parameter defining the 'escape depth' of the photoelectrons and what affect its value.

In a few sentences, explain what is the 'XPS chemical shift', what can it tell about the measured materials, and what are the limitations.